



520.34692V17

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: SORAOKA et al

Serial No.: 10/826,386

Filed: April 19, 2004

For: Vacuum Processing Apparatus And Semiconductor
Manufacturing Line Using The Same

Art Unit: 3652

Examiner: T. Brahan

AMENDMENT AFTER FINAL

Mail Stop: Amendment (Mail Stop AF)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 18, 2006

Sir:

This is in response to the Office Action mailed May 18, 2006, in connection with the above-identified application. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.